



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Patent application of: Tuschel et al. : Group Art Unit: 2877  
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Serial No.: 10/610,481 : Examiner: Layla Lauchman  
:  
Filed: June 30, 2003 :  
:  
For: METHOD FOR RAMAN IMAGING : Attorney Docket No.:  
OF SEMICONDUCTOR : 030354-  
MATERIALS :  
:

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 C.F.R. §§ 1.56 ET SEQ.**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. § 1.97(c), the above-identified Applicants cite the following reference which may be material to the examination of this application and in respect of which there may be a duty of disclosure in accordance with 37 C.F.R. § 1.56. In compliance with 37 C.F.R. § 1.98(d), a copy of the publication set forth below and listed on the attached Form PTO/SB/08B (1 sheet) is enclosed.

**CERTIFICATE OF MAILING UNDER 37 CFR § 1.8**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Name Sharon B. McCullen Signature Sharon B. McCullen Date of Deposit March 10 2006

## PUBLICATIONS

M.D. Schaeberle and P.J. Treado, "LCTF Raman Chemical Imaging of Semiconductors," Proc. Xvth ICORS, S.A. Asher, Ed (Wiley, Chichester, 1996) 1188-1189.

Patrick J. Treado, Joint Venture Advanced Technology Program (ATP) Proposal, April 7, 1998.

The Joint Venture Advanced Technology Program (ATP) Proposal is submitted with confidential financial information redacted from the text as indicated. If the Examiner is interested in reviewing any of the redacted information, he/she is invited to contact the undersigned.

Applicants respectfully request that this item be considered by the Examiner, and that the Examiner acknowledge consideration of this reference by initialing and returning a copy of the enclosed Form PTO/SB/08B with the next official action.

While this Supplemental Information Disclosure Statement may be "material" pursuant to 37 C.F.R. § 1.56, it is not intended to constitute an admission that any information referred to herein is "prior art" for this invention or otherwise material to the patentability of this invention as defined in 37 C.F.R. § 1.56.

In accordance with 37 C.F.R. § 1.97(g), the filing of this Supplemental Information Disclosure Statement shall not be construed as a representation that a search has been made or that other material information as defined in 7 C.F.R. § 1.56(b) exists.

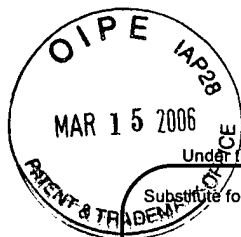
The Commissioner is hereby authorized to charge any fees dues in connection with this submission, including the fee required by § 1.97(c) under § 1.17(p), to Deposit Account No. **50-0310**. A duplicate copy of this page is enclosed.

Respectfully submitted,

Dated: March 10 2006

By: Sharon B McCullen

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)		<b>Complete if Known</b>	
		Application Number	10/610,481
		Filing Date	June 30, 2003
		First Named Inventor	Tuschel et al.
		Art Unit	2877
		Examiner Name	Layla Lauchman
Sheet 1	of 1	Attorney Docket Number	030354

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		M.D. Schaeberle and P.J. Treado, "LCTF Raman Chemical Imaging of Semiconductors," Proc. Xvth ICORS, S.A. Asher, Ed (Wiley, Chichester, 1996) 1188-1189.	
		Patrick J. Treado, Joint Venture Advanced Technology Program (ATP) Proposal, April 7, 1998.	

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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